

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Jouet et al. :
Serial No. : Group Art Unit:
Filed: :
For: PASSIVATION LAYER ON ALUMINUM :
SURFACE AND METHOD THEREOF :

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached hereto is Form PTO-1449 listing U.S. patents as documents believed to be relevant to the subject application. It is respectfully requested that such documents be considered by the Examiner, and an initialed copy of the Form be returned to the undersigned.

This disclosure statement should not be construed as a representation that a search has been made or that no other material information as defined in 37 C.F.R. section 1.56(a) exists.

It is believed that this disclosure complies with the requirements of 37 C.F.R. sections 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures section 609. If for some reason the examiner considers otherwise, it is respectfully requested that the undersigned be promptly informed so that any deficiencies can be remedied.

Copies of the listed documents are submitted herewith.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Mark Homer', with a stylized flourish at the end.

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FORM PTO 1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY DOCKET NO.: NC# 83,960		SERIAL NO.:	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				APPLICANT: Jouet et al.			
(Use several sheets if necessary)				FILING DATE		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	3,165,397	1/12/1965	Lobo	75	0.5	
	AB	3,318,684	5/9/1967	Gernes et al.	75	0.5	
	AC	3,578,436	5/11/1971	Becker et al.	75	0.5	
	AD	5,885,321	3/23/1999	Higa et al.	75	362	
	AE	6,077,329	6/20/2000	Higa et al.	75	722	
	AF	6,179,899	1/30/2001	Higa et al.	75	722	
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	CA	Kinetic Instability of Nanocrystalline Aluminum Prepared by Chemical Synthesis; Facile Room-Temperature Grain Growth, Haber et al., J. Am. Chem. Soc. 1988, 120, 10847-10855.					
	CB						
	CC						
	CD						
EXAMINER				DATE CONSIDERED			
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. include copy of this form with next communication to applicant .							